



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Masamichi NAKASHIBA et al.

: Confirmation No. 9958

Serial No. 09/589,388

: Docket No. 2000-0722

Filed June 8, 2000

: Group Art Unit 3723

APPARATUS FOR AND METHOD
FOR POLISHING WORKPIECE

: Examiner George Nguyen

REC

JAN 09 2004

TECHNOLOGY CENTER R3700

RESPONSE TO ACTION UNDER EX PARTE QUAYLE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEE FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975.

Sir:

In response to the Office Action of September 5, 2003, closing prosecution in the above-referenced U.S. patent application, Applicants hereby address the formal matters raised in the Office Action.

In response to section 2 on page 2 of the Office Action, attached hereto please find a Statement from the Applicant Ebara Corporation noting that the original ribboned patent grant is lost or inaccessible.

With respect to section 3 on pages 2 and 3 of the Office Action, enclosed herewith please find a Supplemental Declaration Under 37 CFR 1.175(b)(1).

In view of the accompanying attachments, it is respectfully submitted that the present application as a whole is now in condition for allowance. Indication of such is respectfully requested.

#30/ statement
re: loss
of patent
M. Waters
1/16/04